### PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date	
Wei-Chun HUA	12/28/2010	
Chung-Long CHANG	12/28/2010	
Chun-Hung CHEN	12/28/2010	
Chih-Ping CHAO	12/28/2010	
Jye-Yen CHENG	01/03/2011	
Hua-Chou TSENG	01/03/2011	

#### **RECEIVING PARTY DATA**

Name:	TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.	
Street Address:	No. 8, Li-Hsin Rd. VI, Hsinchu Science Park	
City:	Hsinchu	
State/Country:	TAIWAN	
Postal Code:	300	

#### PROPERTY NUMBERS Total: 1

Property Type	Number	
Application Number:	12984731	

#### CORRESPONDENCE DATA

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NAME OF SUBMITTER: Benjamin J. Hauptman

REEL: 025586 FRAME: 0545

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PATENT
PEEL: 025586 EPAME

Total Attachments: 2 source=efiledassgn#page1.tif source=efiledassgn#page2.tif

> PATENT REEL: 025586 FRAME: 0546

Docket No.: T5057-B361U

### ASSIGNMENT

In consideration of the premises and other	good and valuable	consideration in	hand paid,	the receipt a	and sufficiency of
which is hereby acknowledged, the undersigned,			. ,	•	Ť

Wei-Chun HUA 1) 4) Chih-Ping CHAO Chung-Long CHANG 2) 5) Jye-Yen CHENG

Chun-Hung CHEN **Hua-Chou TSENG** 

who has made a certain new and useful invention, hereby sells, assigns and transfers unto

# TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD. having a place of business at No.

## 8, Li-Hsin Rd, VI, Hsinchu Science Park, Hsinchu 300, Taiwan R.O.C.

its successors and assigns (hereinafter designated "ASSIGNEE") the entire right, title and interest for the United States of America as defined in 35 U.S.C. 100 in the invention entitled

#### PROTECTION STRUCTURE FOR METAL-OXIDE-METAL CAPACITOR

(a) for which an application for United States Letters Patent was filed on 1-5-2011, and identified by United States Patent Application No. 12/984, 731; or

(b) for which an application for United States Letters Patent was executed on

and the undersigned hereby authorizes and requests the United States Commissioner of Patents and Trademarks to issue any and all United States Letters Patent which may be granted therefore and any and all extensions, divisions, reissues, continuations, or continuations-in-part thereof, and the right to all benefits under the International Convention for the Protection of Industrial Property to the said ASSIGNEE, for its interest as ASSIGNEE, its successors, assigns and legal representatives; the undersigned agrees that the attorneys of record in said application shall hereafter act on behalf of said ASSIGNEE;

AND the undersigned hereby agrees to transfer a like interest, and to render all necessary assistance in making application for and obtaining original, divisional, reissued or extended Letters Patent of the United States, upon request of the said ASSIGNEE, its successors, assigns and legal representatives, and without further remuneration, in and to any improvements, and applications for patent based thereon, growing out of or related to the said invention; and to execute any papers by the said ASSIGNEE, its successors, assigns and legal representatives, deemed essential to ASSIGNEE's full protection and title in and to the invention hereby transferred.

SIGNED on the date indicated aside my signature:

1) Wei-Chun Hua

2) V Clung-Long Chang
Name: Chung Long CMANG

3) Ch Chen Name: Chun-Hung CHEN

V Dec. 28, 20/0
Date:

Dee/28 12010.

Date:

| Dee/28 120 10

4) Ches Po Chus Name: Chih-Ping CHAO	V Dee, 28, 20/0
5) You Charles Yen CHENG	V Jan. 03, 20//
6) V Jana - Chua Jary Name: Hua-Chou TSENG	Date:

PATENT REEL: 025586 FRAME: 0548

**RECORDED: 01/05/2011**